

02910.000080

PATENT APPLICATION



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
	:	Examiner: E. Pert
SEIJI MISHIMA)	
	:	Group Art Unit: 2826
Application No.: 10/665,425)	
	:	
Filed: September 22, 2003)	
	:	
For: METHOD FOR MANUFACTURING)	
AN ELECTRON SOURCE SUBSTRATE :		June 23, 2005

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Office Action dated March 23, 2005, please amend the above-identified application as follows: